



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815

Examiner: Joseph H. Nguyen

In Re PATENT APPLICATION Of:

Applicant: Takashi NOGUCHI

Serial No.: 10/822,691

Filed: April 13, 2004

For: HEAT RADIATION STRUCTURE OF
SEMICONDUCTOR DEVICE, AND
MANUFACTURING METHOD
THEREOF

Atty Ref.: OKI 419

RESPONSE TO
ELECTION OF SPECIES
REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Election Requirement dated March 18, 2005, applicant elects Species I, the embodiment of Figures 1 - 5 for examination. Claims 1 - 20 read on the elected specie. No claim is generic. The election is without traverse.

Applicants maintain the right to filing divisional applications with regard to the non-elected species. Examination of the application on the merits respectfully is requested.

Respectfully submitted,

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April 14, 2005
Date

SMR:pjl

FEE ENCLOSED:\$
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No. 18-0002